

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT

APPLICANT(S):	Yizhou SONG, et al.	DOCKET NO:	P05,0328
SERIAL NO.:	10/550,506	ART UNIT:	1795
FILED:	September 23, 2005	EXAMINER:	Michael A. Band
		CONF. NO.	9959
TITLE:	THIN FILM FORMING METHOD AND FORMING DEVICE THEREFOR		

Commissioner for Patents
PO Box 1450
Alexandria, Virginia 22313-1450

Sir:

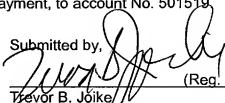
The patents listed on the enclosed PTO/SB/08a are submitted pursuant to 37 CFR § § 1.56, 1.97, and 1.98. As of the date of mailing this Information Disclosure Statement, an Office Action on the merits has been received, but neither a final rejection nor a Notice of Allowance has been received. Moreover, the undersigned hereby certifies pursuant to 37 CFR 1.97(c)(1) that each item of information contained in the Information Disclosure Statement was first cited in a communication from a foreign patent office in counterpart foreign application not more than three months prior to the filing of the Information Disclosure Statement.

Applicants respectfully request that a citation and examination of the references identified on the attached PTO/SB/08a form be made during the course of examination of the above-identified application for United States Patent.

Enclosed is a copy of the Supplementary European Search Report for the Examiner's review.

The Commissioner is hereby authorized to charge any additional fees that may be required, or to credit any overpayment, to account No. 501519.

Submitted by,



(Reg. No. 25,542)

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